

iPLM-43 Polarizing Microscope



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Features and Applications

The iPLM-43 polarizing microscope is an essential instrument for studying and identifying substances with birefringence by utilizing the polarization characteristics of light. It enables users to conduct single polarized observation, orthogonal polarized observation, and conical observation. The center of the Buehler microscope can be adjusted, and it adopts a turntable switching method and a cyclic focusing mode, making the observation of interference patterns more convenient. It is widely used in research and inspection in fields such as geology, chemistry, medicine, and pharmaceuticals. It can also be used for observing the crystal phase of liquid polymer materials, biological polymers, and liquid crystal materials. It is an ideal instrument for research and teaching in scientific research institutions and universities.

Product Features

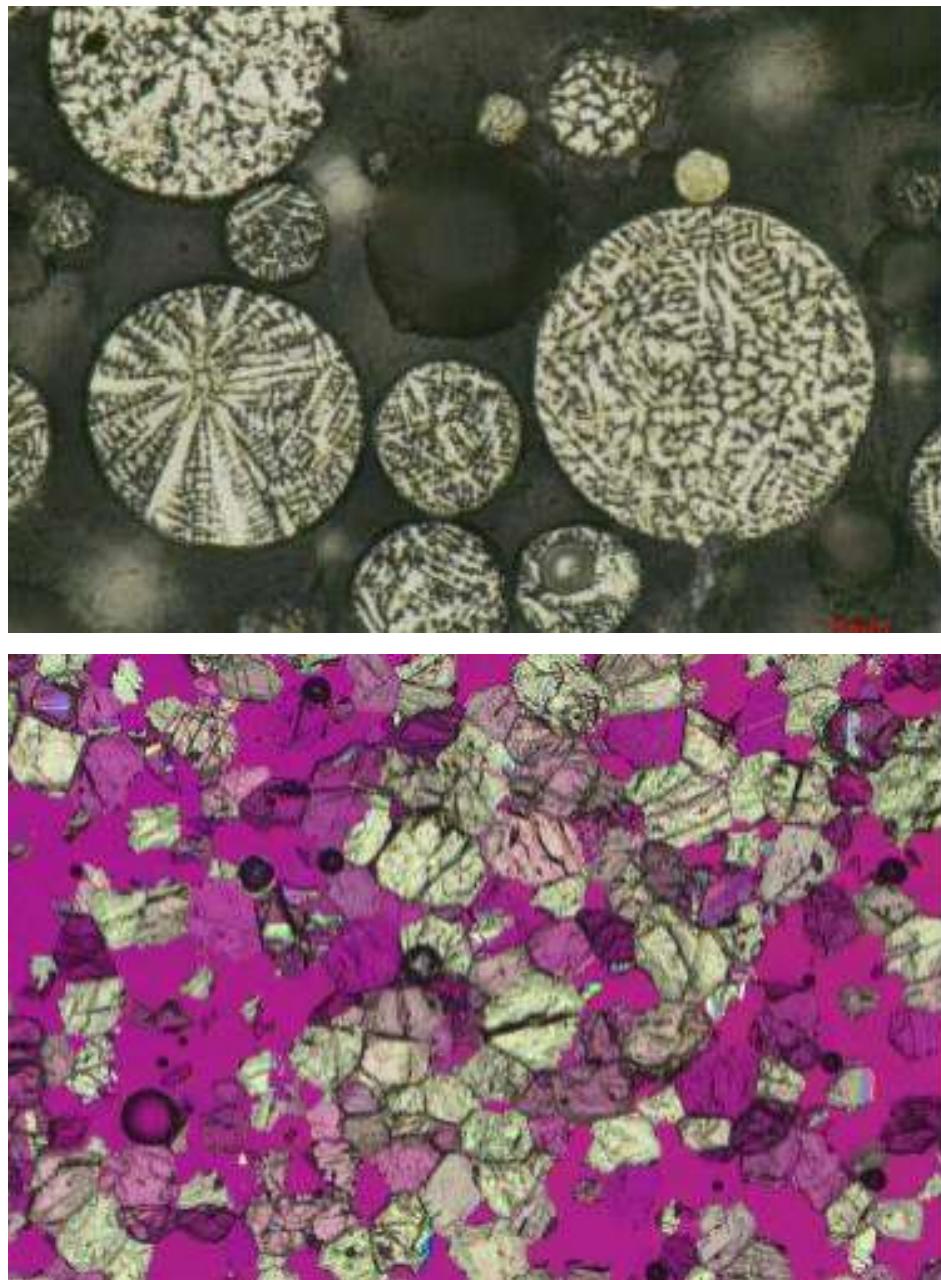
- The T-shaped roof and modular structure are adopted, which is highly rigid, stable and can be flexibly disassembled. The special surface treatment not only enhances aesthetics but also provides practicality. Moreover, it optimizes the concentrated lighting system for energy conservation and environmental protection.
- The reflective illuminator features preset slots and multiple optical components. The polarizer can be removed, enabling both natural light observation and convenient component replacement to meet various needs.
- A 160mm large-diameter graphite-coated worktable with 360° smooth rotation and real-time locking function. Special silk-screened scale lines are used to prevent wear and fading over long-term use.
- A large-aperture telescopic achromatic condenser lens, with adjustable center and elevation, and equipped with a diaphragm, provides sufficient and uniform illumination for observation at various magnifications and photography, resulting in clear images.
- The low-hand position coarse-fine coaxial focusing mechanism, equipped with multiple adjustment and limit devices, provides a comfortable operation. It also enables quick switching of slides and protects the slides as well as the objective lens.
- Integrating hardware with image analysis software, it supports automatic magnification calibration and brightness memory. Combined with professional condenser observation components, it offers precise measurement and efficient observation.



Features and Applications

Product Application

- Geological field: Facilitates the observation of optical properties of rock thin sections, helps in the identification of minerals, and analyzes the structure of rocks and their formation environments.
- Chemical industry: Capable of detecting the crystal phase of liquid polymer materials, assisting in controlling material performance and production quality.
- Research and teaching: Research institutions and universities can utilize this to conduct experimental teaching, thereby cultivating students' abilities in microscopic observation and material analysis.



Product Details

Product Structure



- Professional catadioptric observation intermediate lens group, with built-in Brewster lens, equipped with compensation slot, can be paired with λ plates, $\lambda/4$ plates and quartz wedges.
- The center of the Bessel lens is adjustable. It uses a turntable for switching and a cyclic focusing mode, making the observation of interference patterns much easier.
- The prismatic polarizing beam splitter group can rotate 360°, with a graduation value of 2° and an accuracy of 6'.

Technical Specification

Optical system	Infinite distance chromatic aberration correction optical system
Observation Tube	30° tilt, infinite distance hinge three-way eyepiece, inter-pupillary distance adjustment: 50mm - 75mm, unilateral viewing adjustment: ±5 diopters, two-stage spectral ratio R:T = 100:0 or 50:50
Eyepiece	High-eye-level wide-field flat-field eyepiece SWH10X23mm. The viewing angle is adjustable. It can be equipped with a micrometer scale and a grid plate.
Objective Lens	Infinity-long working distance stress-relieving flat-field objective lenses of 5X, 10X, 20X, and 50X (semi-compensated chromatic aberration correction)
Focus Adjustment Mechanism	Low-position coarse-fine coaxial focusing mechanism. Travel (focusing range) 28mm, fine adjustment accuracy 0.001mm. Equipped with a tension adjustment device to prevent sliding and an upper limit position device to prevent damaging the sections.
Converter	Internal positioning 5-hole adjustable center converter (one of the holes is fixed)
Intermediate Lens Group	Equipped with a push-pull type deviation detection unit, which can be removed from the optical path; internally contains a Bauschleit mirror, and a turntable-type switching mechanism (with adjustable center and focal length)

Standard Delivery

Bias-correcting mirror group	Bias correction mirror group, 360° rotation, resolution 2°, accuracy 6', with locking mechanism
Compensator	λ plate: φ18 mm, Grade 1 Red (wavelength difference 551 nm), λ/4 plate: φ18 mm (wavelength difference 147.3 nm), quartz wedge (grades I - IV)
Workbench	Rotating metal work platform, surface graphite spraying, anti-corrosion and wear-resistant; diameter 160mm, 360° rotation possible, graduation value 1°, accuracy 6', equipped with locking device
Collimator	Swing-out type achromatic collimating mirror with N.A. 1.2
Lighting system	Upper lighting: Reflective lamp chamber 10W LED, preset center, reflective illuminator, with field-of-view diaphragm and aperture diaphragm, including LBD color filter set, with plug-in polarizer set
	Description: 10W LED transmission lamp chamber, preset center, Cora Lighting, with variable field-of-view diaphragm
	Photography and video accessory: 1X, 0.65X, 0.5X C interface, adjustable focus;
Other attachments	4K high-definition imaging system, USB3.0 computer version imaging system, cameras (5 million, 6 million, 12 million, 20 million, etc.) High-precision micrometer, with a graduation value of 0.01mm
	Software (professional measurement system, metallographic analysis system, particle analysis system, porosity analysis system, welding-specific measurement system, etc.)